



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Toshimitsu Taniguchi
Serial No. : 09/891,580
Filed : June 26, 2001
Title : SEMICONDUCTOR DEVICE MANUFACTURING METHOD

Art Unit : 2825
Examiner : IGWE U ANYA

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY

In reply to the action mailed February 4, 2003, please amend the application as indicated on the following pages. Applicant asks that all claims be allowed in view of the amendment to the claims and remarks contained on the following sheets, a total of 9 pages.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: May 5, 2003

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I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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